

21854
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Young-Jin KIM

Serial No.: 09/599,475

Group Art Unit: 2125

Filed: June 22, 2000

Examiner: Garland, Steven R.

For: SEMICONDUCTOR FACTORY AUTOMATION SYSTEM AND METHOD FOR
MONITORING AT LEAST ONE SERVER IN REAL TIME

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INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 9, 2004

RECEIVED

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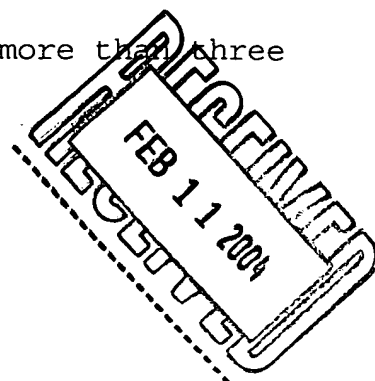
Sir:

Technology Center 2100

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

In accordance with 37 CFR §1.97(c), this Information Disclosure Statement is being filed after the period set forth in 37 CFR §1.97(b), but before the mailing date of either a Final Action under 37 CFR §1.113 or a Notice of Allowance under 37 CFR §1.311.

The patents and publications listed on Form PTO-1449 were cited in a United Kingdom Search Report mailed no more than three



Certification in accordance with 37 CFR § 1.97(e) is included herein. Accordingly, it is respectfully submitted that no fee is required by the filing of this Information Disclosure Statement. Should any fee be required, please charge such fee to Deposit Account No. 06-1358. A duplicate copy of this paper is enclosed.

CERTIFICATION

It is hereby certified that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this statement.

Respectfully submitted,

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Enclosures
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Information Disclosure Statement

U.S. Patent Application Serial No. 09/599,475

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- (1) International Publication No. WO 00/68795 A1
- (2) International Publication No. WO 00/32138 A1
- (3) International Publication No. WO 00/77648 A1